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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Dmitri V. Vezenor et al.

Serial No.: 09/842,214

Title: METHOD OF FABRICATING SUB-MICRON HEMISPHERICAL AND HEMICYLINDRICAL STRUCTURES FROM NON-SPHERICALLY SHAPED TEMPLATES

Filed: April 25, 2001

Attorney Docket No.: 1496.00379

Examiner: Ahmed, S.

Art Unit: 1765

In Response To: Office Action mailed September 20, 2004

CERTIFICATE OF MAILING

I hereby certify that this letter, the response or amendment attached hereto are being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on December 20, 2004.

By:

Jan M. Dunbar
Jan M. Dunbar

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed September 20, 2004 please amend the above-identified application as follows: